

8th International Workshop on Thin Films and New Ideas for Pushing the Limits of RF Superconductivity

Tuesday 09 October 2018

Advanced cleaning of substrates: Chair M. Taborelli - Villi Room (14:40-16:20)

time	[id] title	presenter
14:40	[40] Evaluation of the Copper Polishing procedures in the framework of ARIES H2020 Collaboration	PIRA, Cristian
15:05	[27] Plasma cleaning for LCLS-II cavities	MARTINELLO, Martina
15:30	[8] Optimization of mechanical polishing of Niobium for SRF applications	Mr HRYHORENKO, Oleksandr
15:55	[47] Improvement of Nb thin film on Cu substrate by Nd:YAG laser radiation	Prof. MEDVIDS, Arturs